Synchrotron Radiation to study Atomic Layer Deposition

Monday, 13 June 2016

Talks 1 (09:15 - 13:00)

time [id] title	presenter
09:15 [36] Welcome messages	
09:30 [33] ALD – From Ideal to Real	Prof. NILSEN, Ola
10:15 [21] Epitaxial complex oxide thin films by atomic layer deposition	Dr COLL, Mariona
10:35 Coffee break	
10:55 [1] Controlling the short-range order of amorphous oxides by na	anometer size Mrs ETINGER-GELLER, Yael
11:15 [6] Straightforward conversion of MnO2 to LixMn2O4 by gas-sc	olid reactions Dr MIIKKULAINEN, Ville
11:35 [5] Use of atomic layer deposition for improving pattern transfer self-assembly of PS-b-PMMA	in directed Mrs EVANGELIO, Laura
11:55 [35] Synchrotron Radiation and thin film growth phenomena	FERRER, Salvador
12:40 [29] Characterization Capabilities for Atomic Layer Deposition a Synchrotron Light Source II	at the National Dr ATTENKOFER, Klaus